

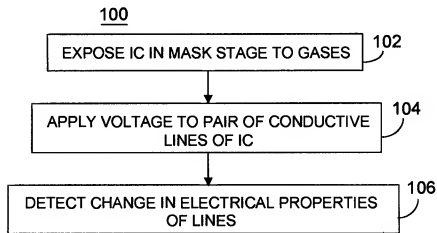
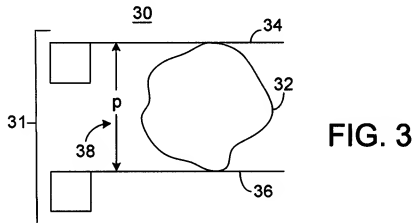
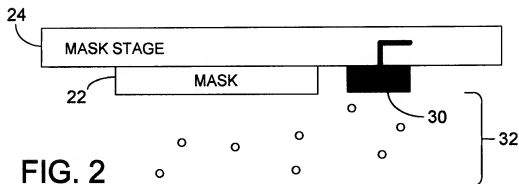
Applicant(s): Kevin J. Orvek
REAL-TIME MONITORING OF PARTICLES IN
SEMICONDUCTOR VACUUM ENVIRONMENT

FIG. 4

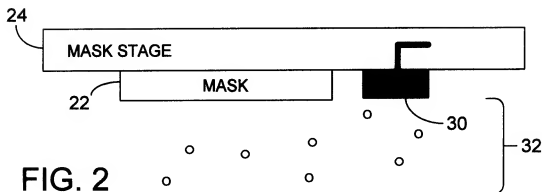


FIG. 2

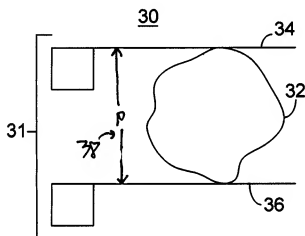


FIG. 3

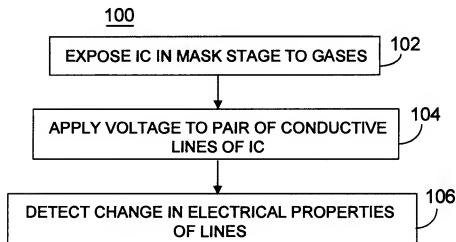


FIG. 4